

Notice of References Cited

Application/Control No.

10/580,166

Applicant(s)/Patent Under
Reexamination
KWON ET AL.

Examiner

DEBORAH A. DAVIS

Art Unit

1655

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,190,757	03-1993	Kim, Young S.	424/728
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	CN 1371978 A	10-2002	China	CHEN L	
	O	JP 05178573 A	07-1993	Japan	MORI et al.	
	P	JP 2002068931 A	03-2002	Japan	IKEMOTO et al.	
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	STN CAS Registry
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.